

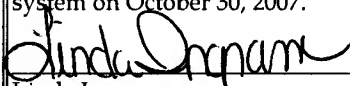
REPLY UNDER 37 CFR §1.116
EXPEDITED PROCEDURE
TECHNOLOGY CENTER 1700

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:	§	Attorney Docket No.
Huan-Just Lin, et al.	§	2003-0065 / 24061.508
	§	
Serial No.: 10/688,045	§	Customer No. 42717
	§	
Filed: October 17, 2003	§	Group Art Unit: 1722
	§	
For: FULLY DRY, Si RECESS FREE	§	Examiner: Robert M. Kunemund
PROCESS FOR REMOVING	§	
HIGH K DIELECTRIC LAYER	§	Confirmation No.: 9213

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I hereby certify that this correspondence (including any listed enclosures) is being electronically filed in the United States Patent and Trademark Office via the EFS-Web system on October 30, 2007.


Linda Ingram

Sir:

RESPONSE UNDER 37 CFR §1.116

This Response is submitted in reply to the Office Action mailed on October 4, 2007.
(Please see the pages that follow).